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By

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Attorney Docket No. 100806-17282 (NECK 17.552)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Hiroshi TANABE

Serial No.: 09/614,286

Filed: July 12, 2000

Title: **METHOD FOR FORMING SEMICONDUCTOR...**

Examiner: Timothy J. Sutton

Art Unit: 2813

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Assistant Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

SIR:

In order to comply with discretionary rules 37 CFR §§1.97 and 1.98, attached hereto is a copy of Form PTO-1449 and copies of the documents listed thereon. These documents contain information which the Examiner may consider to be important in deciding whether to issue a patent in the instant application.

As this statement is being filed after issuance of a final Office Action, a fee of \$180.00 accompanies this document in accordance with 37CFR §§1.97(c) and 1.17(p).

KR Patent Application No. 1999-023628 is a corresponding filing of JP 11-064883 dated March 3, 1999, and KR Patent Application no. 1999-0031801 is a corresponding filing of US 2001/0012702 dated August 9, 2001.

Attached is a copy of a Korean Office Action dated June 25, 2002 from the corresponding International Patent Application. All of the documents listed in Form PTO-1449 appear in the Korean Office Action.

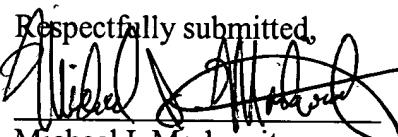
As some of these documents are written in a language other than English, English Language abstracts and translations are annexed thereto explaining their relevancy in accordance with 37 CFR §1.98(a)(3).

Each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

The present Information Disclosure Statement is being submitted in compliance with 37 §CFR 1.56 as an Examiner might consider any cited document important in deciding whether to allow the application to issue as a patent, but the citation of each document is not to be construed as an admission that such document is necessarily relevant or prior art. No representation is intended that the cited documents represent the results of a complete search, and it is anticipated that the Examiner in the normal course of examination, will make an independent search and will determine the best prior art consistent with 37 CFR 1.104 (a), and in the course of such search will review for relevance every document cited on the attached form even if not initialed.

Early and favorable consideration is respectfully solicited.

Any fee due with this paper may be charged on Deposit Account 50-1290.

Respectfully submitted,

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